Electronic Patent Application Fee Transmittal							
Application Number:	108	10802087					
Filing Date:	16-	16-Mar-2004					
Title of Invention:	Me	Method and system for immersion lithography lens cleaning					
First Named Inventor/Applicant Name:	Ch	Ching-Yu Chang					
Filer:	Jos	Joseph R. Mencher/Y. Kim Reyes					
Attorney Docket Number:	200	2003-1435 / 24061.911					
Filed as Large Entity							
Utility under 35 USC 111(a) Filing Fees							
Description		Fee Code	Quantity	Amount	Sub-Total in USD(\$)		
Basic Filing:							
Pages:							
Claims:							
Miscellaneous-Filing:							
Petition:							
Patent-Appeals-and-Interference:							
Filing a brief in support of an appeal		1402	1	540	540		
Post-Allowance-and-Post-Issuance:							
Extension-of-Time:							

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Miscellaneous:				
	Total in USD (\$)			540